



AP/2876
Jhw/A

PATENT
Atty. File No: 83975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Satoshi Kitagawa

Serial No.: 09/696,117

Filed: October 25, 2000

For: **MARKING METHOD FOR SEMICONDUCTOR
WAFER**

Examiner: Lisa M. Caputo

) Confirmation No. 4414

) Group Art Unit: 2876

) *I hereby certify that this correspondence is
) being deposited with the United Postal Service
) as first class mail in an envelope addressed to:
) Mail Stop AMENDMENT, Commissioner for
) Patents, P.O. Box 1450, Alexandria, VA,
) 22313-1450, on November 8, 2004*

) 
) Gerald T. Shekleton, Reg. No 27,466

AMENDMENT

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*Entered
12/7/04
ahw*

Dear Sir:

The Office Action of August 12, 2004 has been carefully reviewed and the following amendments and remarks are made in response thereto.

Ok to enter the 11/24/04